

Supplementary Information

Investigation on Photopolymerization of PEGDA to Fabricate High-Aspect-Ratio Microneedles

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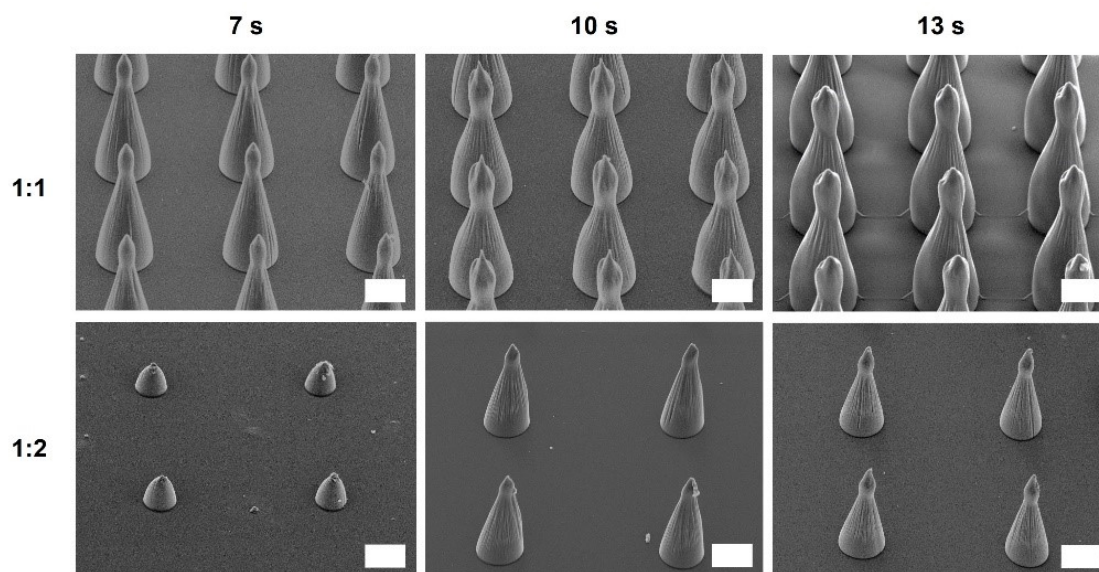


Figure S1. SEM images of MNs according to the spacing ratio between MNs and UV exposure time. Scale bar = 100 μm .